

IPW

IR-2550 DIV (2-3619)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Martin Standing, et al.

Date: July 19, 2004

Serial No.: 10/634,447

Group Art Unit: 2811

Filed: August 5, 2003

Examiner: Unassigned

For: CHIP SCALE SURFACE MOUNTED DEVICE AND PROCESS OF MANUFACTURE

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUBMISSION

Sir:

In compliance with the duty of disclosure under 37 C.F.R. §1.56 and in accordance with the practice under 37 C.F.R. §§1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Also enclosed are copies of Japanese Publication No. 5-129516 and an English language translation of the Abstract. Copies of the U.S. patents may be provided upon request. The Examiner is respectfully requested to consider these references and to make them of record in the present application by initialing the enclosed Form PTO-1449 and returning it to applicant's representative with the next communication concerning the application.

No fee is believed to be due with this submission since it is being made prior to issuance of a first Office Action concerning the application. Should any fee be due, however, authorization is hereby provided to charge such fee to Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner of Patents and Trademarks, P.O. Box 1450, Alexandria, VA 22313-1450, on July 19, 2004:

Kourosh Salehi

Name of applicant, assignee or  
Registered Representative

Signature

July 19, 2004

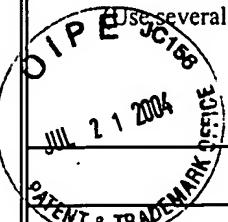
Date of Signature

SHW:KS:ck

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Respectfully submitted,

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<b>APPLICANT'S ART CITATION</b> <small>Use several sheets if necessary)</small> 		Application 10/634,447		OFGS File No. IR-2550 DIV (2-3619)		
		Applicant Martin Standing, et al.				
		Filing Date August 5, 2003		Group Art Unit 2811		
		<b>U.S. PATENT DOCUMENTS</b>				
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	
	US-6,391,687	05-2002	CABAHUG ET AL.			
	US-6,133,634	10-2000	JOSHI			
	US-5,814,894	09-1998	IGARASHI ET AL.			
	US-5,739,585	04-1998	AKRAM ET AL.			
	US-5,734,201	03-1998	DJENNAS ET AL.			
	US-5,729,440	03-1998	JIMAREZ ET AL.			
	US-5,726,502	03-1998	BEDDINGFIELD			
	US-5,726,501	03-1998	MATSUBARA			
	US-5,726,489	03-1998	MATSUDA ET AL.			
	US-5,703,405	12-1997	ZEBER			
<b>FOREIGN PATENT DOCUMENTS</b>						
Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
					Yes	No
5-129516	05-1993	JAPAN			X (Abstract)	
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)						
Examiner		Date Considered				
<small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.</small>						

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<b>U.S. PATENT DOCUMENTS</b>						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	
	US-5,654,590	08-1997	KURAMOCHI			
	US-5,578,869	11-1996	HOFFMAN ET AL.			
	US-5,554,887	09-1996	SAWAI ET AL.			
	US-5,532,512	07-1996	FILLION ET AL.			
	US-5,512,786	04-1996	IMAMURA ET AL.			
	US-5,510,758	04-1996	FUJITA ET AL.			
	US-5,477,087	12-1995	KAWAKITA ET AL.			
	US-5,454,160	10-1995	NICKEL			
	US-5,448,114	09-1995	KONDOH ET AL.			
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<b>FOREIGN PATENT DOCUMENTS</b>						
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<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-5,397,921	03-1995	KARNEZOS				
	US-5,394,490	02-1995	KATO ET AL.				
	US-5,381,039	01-1995	MORRISON				
	US-5,371,404	12-1994	JUSKEY ET AL.				
	US-5,367,435	11-1994	ANDROS ET AL.				
	US-5,313,366	05-1994	GAUDENZI ET AL.				
	US-5,311,402	05-1994	KOBAYASHI ET AL.				
	US-5,217,922	06-1993	AKASAKI ET AL.				
	US-4,604,644	08-1986	BECKHAM ET AL.				
	US-4,021,838	05-1977	WARWICK				
<b>FOREIGN PATENT DOCUMENTS</b>							
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Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-3,972,062	07-1976	HOPP				
	US-3,871,014	03-1975	KING ET AL.				
	US-3,561,107	02-1971	BEST ET AL.				
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